

Attorney's Docket No.: 8034 USA/W-C/W-C/HMM

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Patent Application of:

Christopher Laurent Beaudry, et al.

Application No: 10/736,007

Filing Date: December 15, 2003

For: SINGLE WAFER CLEANING METHOD TO REDUCE PARTICLE **DEFECTS ON A WAFER SURFACE**

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Duy V.N. Deo

1765

Examiner:

Art Unit:

AMENDMENT AND RESPONSE

Dear Sir:

This is in response to the Office Action mailed April 6, 2006. Applicant respectfully requests the Examiner to enter the following amendments and consider the following remarks.:

FIRST CLASS CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450

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